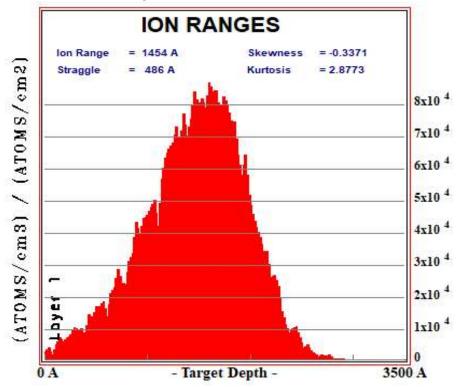
# **Boron in Silicon implant**



#### 9999 Ions Calculated

Ion Type = B Ion Energy = 40 keV Ion Angle = 0

#### Calculation Parameters:

Backscattere	d lons	80	
Transmitted I	1		
Vacancie	299.5		
ION STATS	Range	Straggle	
Longitudinal	1454 A	486 A	
Lateral Proj.	443 A	551 A	
Radial	691 A	345 A	

### Type of Damage Calculation

Quick: Kinchin-Pease

# **Stopping Power Version**

SRIM-2008

% ENERGY	LOSS lons	Recoils
Ionization	63.07	7.97
Vacancies	0.25	1.24
Phonons	0.87	26.60

SRIM-2008.04 October 27, 2024 www.SRIM.org

#### SPUTTERING YIELD

	Atoms/lon	eV/Atom	
TOTAL			
Si	0.000000	0.00	

# **Target layers:**

	Layer Name	Width (A)	Density	Si (28.086)	Solid/Gas	Stop Corr.
-	Layer 1	3000	2.321	1.00000	Solid	1
	Lattice Binding Energy			2		
	Surface Binding Energy		4.7			
E	Displacement Energy			15		